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OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Makoto
Family Name:: IIDA
City of Residence:: Fukushima
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Application Type:: National Phase
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: A METHOD FOR PRODUCING SEMICONDUCTOR WAFERS AND A SYSTEM FOR DETERMINING A CUT POSITION IN A SEMICONDUCTOR INGOT
Attorney Docket Number:: 128768
Suggested Drawing Figure:: 1
Total Drawing Sheets:: 3
Small Entity:: No

Representative Information

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Domestic Priority Information	
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Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Phase of	PCT/JP2005/000641	01/20/05
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-026887	02/03/04	Yes
Assignee Information			
Assignee Name::	Shin-Etsu Handotai Co., Ltd.		
Street of mailing address::	4-2, Marunouchi 1-chome		
City of mailing address::	Chiyoda-ku		
State or Province of mailing address::	Tokyo		
Country of mailing address::	Japan		